Notice of References Cited Application/Control No. 10/736,333 Applicant(s)/Patent Under Reexamination PANDITHARADHYA ET AL. Examiner Cong-Lac Huynh Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0140308 A1	07-2003	Murthy et al.	715/500
*	В	US-2005/0114405 A1	05-2005	Lo, Wei-Lun	707/200
*	С	US-2005/0125720 A1	06-2005	Little et al.	715/513
*	D	US-2005/0138553 A1	06-2005	Ballard et al.	715/530
*	E	US-2006/0117250 A1	06-2006	Rothschiller et al.	715/513
	F	US-			
	G	US-		·	
1	Н	US-			
	Т	US-			
	J	US-			
	К	US-			
N III	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0					
	Р					
	Q					, , , , , , , , , , , , , , , , , , ,
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.